

**Notice of References Cited**

Application/Control No.

09/670,119

Applicant(s)/Patent Under  
Reexamination  
YUMIBA ET AL.

Examiner

Shin-Hon Chen

Art Unit

2131

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2001/0019615	09-2001	KATO et al.	380/286
	B	US-6,694,023	02-2004	Kim, Byung-Jun	380/203
	C	US-6,611,534	08-2003	Sogabe et al.	370/471
	D	US-RE37,052	02-2001	Park, Tae Joon	380/203
	E	US-6,347,846	02-2002	Nakamura, Seiichi	380/203
	F	US-6,266,481	07-2001	Lee et al.	386/94
	G	US-6,021,199	02-2000	Ishibashi, Yasuhiro	380/217
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

